

00862.109138.



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
: Examiner: Calvin Lee
YOSHINOBU SEKIGUCHI, et al.)
: Group Art Unit: 2818
Application No.: 10/566,170)
: 371(c) Date: January 27, 2006)
: For: SEMICONDUCTOR FILM)
MANUFACTURING METHOD :
AND SUBSTRATE)
MANUFACTURING METHOD : January 15, 2008

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on

January 15, 2008

(Date of Deposit)

Damond E. Vadnais, Reg. No. 52,310

(Name of Attorney for Applicants)

Signature

January 15, 2008

Date of Signature

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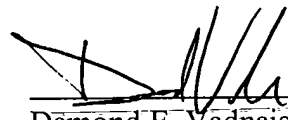
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We also enclose a check for \$180.00 to cover the Information Disclosure Statement under 37 C.F.R. § 1.97(c)(2). Any overpayment should be credited and any deficiency should be charged to Deposit Account No. 06-1205.

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicants' undersigned attorney may be reached in our Costa Mesa, California office at (714) 540-8700. All correspondence should continue to be directed to our below-listed address.

Respectfully submitted,



Damond E. Vadnais
Attorney for Applicants
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